

**PATENT**



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: WHONCHEE LEE  
APPLICATION No.: 10/783,763  
FILED: FEBRUARY 20, 2004  
FOR: **METHODS AND APPARATUSES FOR  
ELECTROCHEMICAL-MECHANICAL  
POLISHING**

EXAMINER: KIN-CHAN CHEN

ART UNIT: 1765

CONF. NO: 7390

**Amendment Under 37 C.F.R. § 1.116**

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The present communication responds to the Office Action dated April 26, 2006 in the above-identified application. Please consider the application in light of the following remarks.

The pending claims are presented in the listing of claims beginning on page 2.

*reconsideration  
request only.*

*KCC.*